IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yan Borodovsky	Art Unit:	1756
Serial No.:	10/681,030	Examiner:	Daborah Chacko Davis
Filed:	October 7, 2003	Assignee:	Intel Corporation
Title:	COMPOSITE OPTICAL LITHOGRAPHY METHOD FOR PATTERNING LINES OF SIGNIFICANTLY DIFFERENT WIDTHS		

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
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AMENDMENT

In response to the Office action mailed March 9, 2007, please reconsider this application in light of the following:

Amendments to the Claims set forth in the **Listing of Claims** beginning on page 2; and

Remarks beginning on page 7.